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S/N 10/682229

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	TABARA	Examiner:	G. Goudreau
Serial No.:	10/682229	Group Art Unit:	1763
Filed:	October 8, 2003	Docket No.:	12844.0045US01
Title:	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on August 16, 2006.

By: 

Name: Gina M. Dahl

CHANGE OF CORRESPONDENCE ADDRESSCommissioner for Patents
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Dear Sir:

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Respectfully submitted,

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